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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/905,320
Filing Date July 13, 2001
Inventor Cem Basceri
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Eric B. Fuller
Attorney's Docket No. MI22-1657
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium
Titanate Comprising Dielectric Layers, including such Layers having a Varied
Concentration of Barium and Strontium within the Layer.

RULE 312 RESPONSE

To: Mail Stop Issue Fee
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

VIA EXPRESS MAIL

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This is responsive to the Notice of Allowance dated November 17,
2003.

Claims 1-8, 17-22 and 52-66 are in the application. However, the
Notice of Allowability excludes indication of allowance of claim 66. This is
believed to be an oversight.